he Application of:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MURAKAMI et al.

Serial No.: 09/991,280

Filed: November 15, 2001

Atty. File No.: 2933PE-2

For: "FLOW CONTROL VALVE

COUPLING STRUCTURE"

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit:

Examiner:

SUPPLEMENTAL INFORMATION **DISCLOSURE STATEMENT**

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO COMMISSIONER OF PATENTS AND TRADEM KS. WASHINGTON, DC

SHERIDAN ROSS P.C.

Pursuant to Applicants' duty of disclosure under 37 CFR § 1.56 and 37 CFR §§ 1.97-1.98, Applicants hereby provide a copy of each of the documents identified on the enclosed PTO Form 1449, although Applicants do not admit that any of such documents, alone or in any combination, are considered to be material to patentability as defined in 37 CFR § 1.56(b). Moreover, the inclusion of these documents is not to be construed as an admission by Applicants that each such document is prior art as to the above-identified patent application.

With respect to references not in English, pursuant to MPEP 609A(3), Applicants are submitting the English language European Search Report issued from corresponding European Patent Application Serial No. 01126563.4.

Respectfully submitted,

RECEIVED

SHERIDAN ROSS P.C.

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